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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroaki TAKAIWA et al.

Group Art Unit: 2851

Application No.: 10/587,268

Examiner: M. LIU

Filed: July 26, 2006

Docket No.: 128865

For: IMMERSION EXPOSURE APPARATUS AND DEVICE MANUFACTURING  
METHOD WITH LIQUID DETECTION APPARATUS (AS AMENDED)

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the June 25, 2008 Office Action, the shortened statutory period for reply  
being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Specification;**

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**